



PATENT APPLICATION

REF # 2nd

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Satoshi YAMADA et al.

Group Art Unit: 2178

Application No.: 10/800,846

Examiner: D. FABER

Filed: March 16, 2004

Docket No.: 118832

For: TEMPLATE PRODUCTION SYSTEM,  
LAYOUT SYSTEM, TEMPLATE  
PRODUCTION PROGRAM LAYOUT  
PROGRAM LAYOUT TEMPLATE DATA  
STRUCTURE, TEMPLATE PRODUCTION  
METHOD, AND LAYOUT METHOD

MAIL STOP RCE

**LARGE ENTITY REQUEST FOR  
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

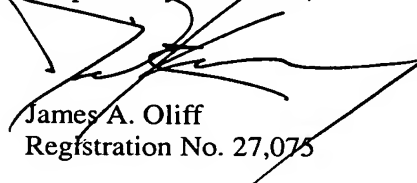
In accordance with the provisions of 37 C.F.R. §1.114, Applicant(s) hereby request(s)  
continued examination.

☒ Applicants further request entry and consideration of the submission filed September 26,  
2006.

The above-identified application was filed on or after June 8, 1995. Thus, entry is proper  
under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 185599 in the amount of ☒ \$790.00 as payment of the fees  
set forth in 37 C.F.R. §1.17(e). The Commissioner is hereby authorized to charge any additional fees  
or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two  
duplicate copies of this page are enclosed.

Respectfully submitted,

  
James A. Oliff  
Registration No. 27,075

David R. Kemeny  
Registration No. 57,241

JAO:DRK/kxs

Date: October 26, 2006

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10/27/2006 NGUYEN 00000093 10000046  
01 FC:1001

790.00 OP

**DEPOSIT ACCOUNT USE  
AUTHORIZATION**

Please grant any extension  
necessary for entry;  
Charge any fee due to our  
Deposit Account No. 15-0461